- 4.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

OSAMU NAKAMURA

U.S. Serial No.

Filed: September 4, 2002

SUSCEPTOR FOR VAPOR-PHASE GROWTH APPARATUS

Alexandria, Virginia September 4, 2002

Honorable Commissioner of Patents and Trademarks Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §1.97

Dear Sir:

Applicant is submitting herewith a copy of the following patent document:

Japanese Published Application No. 63-58819.

The above listed document is set forth together with the applicant and issue or publication date thereof in the attached PTO Form 1449.

Respectfully submitted,

OSAMU NAKAMURA

Mary J. Breiner, Attorney Registration No. 33,161 115 North Henry Street

P.O. Box 19290

Alexandria, Virginia 22320-0290

Telephone: (703) 684-6885

Attachments - PTO Form 1449 w/l Document

1

Substitute for Form 1449A/PTO	Complete if Known
INFORMATION DISCLOSURE STATEMENT BY APPLICANT	Application Number Filing Date: September 4, 2002 First Named Inventor: Osamu Nakamura Group Art Unit:
Sheet 1 of 1	Examiner Name: Attorney Docket Number: 4561/Reissue

U.S. PATENT DOCUMENTS						
Examiner Initials¹	Cite No.	U.S. Patent Doc	Kind Code	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Figures Appear

FOREIGN PATENT DOCUMENTS							
Examiner Initials ¹	Cite No.	Foreign Patent	Kind Code	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Figures Appear	T²
		63-58819		Japan	03/14/1998		*
 							

* English Abstract attached.

		T
Examiner	Date	*
Signature	Considered	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Translation attached.